

MAR 19 2003

GROUP 1700

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Steven A. VAN SLYKE, *et al.*

Group Art Unit: 1763

Serial No.: 09/996,415

Examiner: Buecker, R.

Filed: November 28, 2001

Attorney Docket No.: 83401RLO  
(Rossi Docket No: KODA:296)For: THERMAL PHYSICAL VAPOR DEPOSITION SOURCE FOR MAKING AN ORGANIC LIGHT-  
EMITTING DEVICEAssistant Commissioner for Patents  
Washington, D.C. 20231Certificate of Filing By FacsimileI hereby certify that this paper is being transmitted via  
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Trademark Office, Technology Center 1700, at telephone  
number: 703-872-9310Date: 03/17/03By: M. A. Rossi

Marc A. Rossi

AMENDMENT & REQUEST FOR RECONSIDERATION  
WITH PETITION FOR TIME EXTENSION

Sir:

In reply to the October 16, 2002 Office Action, this application has been amended as indicated below. A marked up version showing the incorporated changes is attached.

IN THE CLAIMS:

*Kindly replace claims 1 and 2 with the following corresponding replacement claims:*

Claims 1 and 2 have been amended as follows:

--1. (Twice Amended) A thermal physical vapor deposition source for vaporizing solid organic materials and applying a vaporized organic material as a layer onto a surface of a structure in a chamber at reduced pressure in forming an organic light-emitting device (OLED), comprising:

a) a bias heater defined by side walls and a bottom wall, the side walls having a height